Substitu	e for form 1	H9A/PTO		Complete if Known						
INEV	DMAT	TION DISC	OCLIDE	Application Number	Application Number 10/658,472					
				Filing Date			September 10, 2003			
SIA		NT BY APP		First Named Invent	First Named Inventor			Hideakazu MIYAIRI et al.		
l	(rate as w	ethy sheets as access	איניי	Art Unit			2828			
				Examiner Name			Philip Nguyen			
Sheet	et 1 of 1			Attorney Docket Number		740756-2650		* · · · · · · · · · · · · · · · · · · ·		
							7.4073			
				U.S. PATENT DOC	UMEN	rs				
Praminer Initials	Cho Na.	U.S. Parent Dooment Number - Kind Code (j/ kepwa)		Publication Date		Name of Patentian or		Pages, Columns, Lines, Where		
	1			MC4-DD-YYY	Ŷ	Applicant of Cltra Document				
						<u></u>		read Appar		
PN		US-6,166,845		12/26/2000		Ito et al.				
PN		US-2004/0203248 A1		10/14/2004		Miyairi et al.				
	-	US-								
	_	UG.								
		US-				<u> </u>			·	
		US-	·							
		US-						ļ <u></u>		
		US-					_			
		US-								
		US-		<u>l</u>		1		<u> </u>		
			FO	REIGN PATENT D	OCUM	ENTS				
Paraminer Inhists	Clac No.1	Foreign Process Decomens		Publication Date		Name of Paramoser		Pages Column, Lines, Where Relevant Passages or Relevant		
		Country Code ² Numb	Kind Code (V Incum)	H04-DD-YYYY	Аррі	olication of Cited Document		Figures Appear T		
	_				1					
					-					
							==		ļ	
		<u></u>								
		0	THER PRIOR A	RT – NON PATENT L	MERAT	URE DOCUMEN	rs .		_	
Examiner Initials	Cite No.1									
	 	Hideaki KUSA	MA, "EXC	MER LASER AT	VNEA	LING APPAR	ATUS'	'. Liquid Crystal	—	
PN	}	Hideaki KUSAMA, "EXCIMER LASER ANNEALING APPARATUS", Liquid Crystal Display Technology 2001, Liquid Crystal Display Manufacturing Technology Edition,							1	
		pp. 138-141; July 1, 2001. (Japanese Article with Full Translation)								
Description	 _				1 15000					
Examiner Signature	/P	hillip Ng	uyen/ ((9/07/2006)	Consid	tered				

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicam.

¹ Applicant's unique citation designation number (optional). ¹ See Kinds Codes of USPTO Patent Documents at www.usoto.gov or MPEP 901.04. ² Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is anached.

¹ Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is